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SERIAL NUMBER 09/775,209	FILING OR 371(c) DATE 02/01/2001 RULE	CLASS 356	GROUP ART UNIT 2877	ATTORNEY DOCKET NO. JG-SU-5038 / 500577.2	
APPLICANTS Mohammad B. Shabani, Tokyo, JAPAN; Shigeru Okuuchi, Tokyo, JAPAN; ** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/13/2001					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <u> </u> Examiner's Signature <u> </u> Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
ADDRESS 26418					
TITLE METHOD FOR ANALYZING IMPURITIES IN A SILICON SUBSTRATE AND APPARATUS FOR DECOMPOSING A SILICON SUBSTRATE THROUGH VAPOR-PHASE REACTION					
FILING FEE RECEIVED 1010	FEES: Authority has been given in Paper No. <u> </u> to charge/credit DEPOSIT ACCOUNT No. <u> </u> for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other <u> </u> <input type="checkbox"/> Credit		